

May 13, 2014

Consolidated Financial and Business Data for the Year ended March 31, 2014

(From April 1, 2013 to March 31, 2014) Nikon Corporation

		2013/3 2014/3		2015/3			
	Ī	1H	Total	1H	Total	1H(est.)	Total(est.)
	Net Sales	497.2	1,010.4	470.4	980.5	410.0	940.
Corporate	Operating Income	37.1	51.0	21.9	62.9	10.0	63.
	Ordinary Income	39.5	48.3	20.0	61.7	12.0	66
	Net Income	32.0	42.4	13.6	46.8	8.0	45
Precision	Net Sales	80.4	179.0	79.8	205.4	70.0	210
Equipment	Operating Income	7.2	13.0	3.7	20.0	-4.0	19
Tura sin s	Net Sales	381.0	751.2	352.5	685.4	300.0	630
Imaging	Operating Income	41.8	60.7	30.9	64.2	27.0	66
Instruments	Net Sales	23.7	53.8	26.0	64.7	30.0	70
Instruments	Operating Income	-2.9	-4.9	-3.4	-2.1	-2.0	1
Other	Net Sales	12.0	26.3	11.9	24.9	10.0	30
Other	Operating Income	1.6	3.5	1.9	4.4	2.0	5
Corporate Expe	enses	-10.6	-21.6	-11.4	-24.0	-13.0	-28
2. Exchange	e Rate(Yen)	1H	Total	1H	Total	Total(est.)
2. Exchange	e Rate(Yen)						
2. Exchange						·	-
2. Exchange	US\$	79	83	99	100	100)
2. Exchang						·)
	US\$	79 101	83	99	100	100)
3. Unit Sale Semiconductor	US\$ Euro	79 101	83	99	100	100	
3. Unit Sale	US\$ Euro	79 101 aphy Systems	83 107	99 130	100 134	100 140	
3. Unit Sale Semiconductor Lithography	US\$ Euro es of Nikon Lithogra New products	79 101 aphy Systems	83 107	99 130 10	100 134	100 140	
3. Unit Sale Semiconductor Lithography Systems	US\$ Euro es of Nikon Lithogra New products Refurbished Products	79 101 aphy Systems 9 5	25 15	99 130 10 2	100 134 32 8	100 140 34 14	
3. Unit Sale Semiconductor Lithography Systems FPD Lith	US\$ Euro es of Nikon Lithogra New products Refurbished Products Total hography Systems	79 101 aphy Systems 9 5 14 25	25 15 40 43	99 130 10 2 12 35	100 134 32 8 40 56	100 140 34 14 48 34	
3. Unit Sale Semiconductor Lithography Systems FPD Lith	US\$ Euro es of Nikon Lithogra New products Refurbished Products Total	79 101 aphy Systems 9 5 14 25	25 15 40 43	99 130 10 2 12 35	100 134 32 8 40	100 140 34 14 48 34	
3. Unit Sale Semiconductor Lithography Systems FPD Lith	US\$ Euro es of Nikon Lithogra New products Refurbished Products Total hography Systems s of Nikon Semicond	79 101 aphy Systems 9 5 14 25	25 15 40 43 aphy Systems by	99 130 10 2 12 35 7 Technology	100 134 32 8 40 56	100 140 34 14 48 34 urbished	
3. Unit Sale Semiconductor Lithography Systems FPD Lith	US\$ Euro es of Nikon Lithogra New products Refurbished Products Total hography Systems s of Nikon Semicond i-line	79 101 aphy Systems 9 5 14 25	25 15 40 43 aphy Systems by 16 3	99 130 10 2 12 35 7 Technology	100 134 32 8 40 56 *Including ref	100 140 34 14 48 34 urbished	
3. Unit Sale Semiconductor Lithography Systems FPD Lith	US\$ Euro Property of Nikon Lithogra New products Refurbished Products Total Thography Systems Sof Nikon Semicond i-line KrF	79 101 aphy Systems 9 5 14 25	25 15 40 43 aphy Systems by	99 130 10 2 12 35 7 Technology	100 134 32 8 40 56 *Including ref	100 140 34 14 48 34 Surbished 18 6	
3. Unit Sale Semiconductor Lithography Systems FPD Litt 4.Unit Sales	US\$ Euro Pes of Nikon Lithogra New products Refurbished Products Total hography Systems S of Nikon Semicond i-line KrF ArF ArF imm.	79 101 aphy Systems 9 5 14 25 ductor Lithogra	25 15 40 43 aphy Systems by 16 3 8 13	99 130 10 2 12 35 7 Technology 6 3 3 0	100 134 32 8 40 56 *Including ref 12 8 11 9	100 140 34 14 48 34 2urbished 18 6 6	
3. Unit Sale Semiconductor Lithography Systems FPD Litt 4.Unit Sales	US\$ Euro es of Nikon Lithogra New products Refurbished Products Total hography Systems s of Nikon Semicond i-line KrF ArF	79 101 aphy Systems 9 5 14 25 ductor Lithogra	25 15 40 43 aphy Systems by 16 3 8 13	99 130 10 2 12 35 7 Technology 6 3 3 0	100 134 32 8 40 56 *Including ref 12 8 11	100 140 34 14 48 34 2urbished 18 6 6	
3. Unit Sale Semiconductor Lithography Systems FPD Litt 4.Unit Sales	US\$ Euro PS of Nikon Lithogra New products Refurbished Products Total hography Systems S of Nikon Semicond i-line KrF ArF ArF ArF imm.	79 101 aphy Systems 9 5 14 25 luctor Lithogra 6 1 1 6 ography System	25 15 40 43 aphy Systems by 16 3 8 13	99 130 10 2 12 35 7 Technology 5 6 3 3 0	100 134 32 8 40 56 *Including ref 12 8 11 9	100 140 34 14 48 34 Furbished 18 6 6	

^{*} Effective April 2014, IC steppers and scanners are called Semiconductor Lithography Systems and LCD steppers and scanners are called FPI Lithography Systems.

6. Unit Sales of Nikon Digital Imaging Products (Unit: thousands units)

Digital camera—Interchangeable Lens Type	3,450	6,980	2,980	5,750	5,400
Interchangeable Lens	4,770	9,710	4,200	8,230	7,450
Compact DSC	8,260	17,140	5,800	11,160	9,000

7.Capital Expenditure, Depreciation & Amortization, R&D Expenditure (Unit: Billions of Yen)

		2013/3		2014/3		2015/3
		1H	Total	1H	Total	Total(est.)
	Capital Expenditure Depreciation & Amortization R&D Expenditure	34.7	60.1	25.7	45.4	39.0
Corporate		16.8	36.2	19.9	42.4	38.0
		36.4	76.4	40.8	74.5	70.0
· ·	Capital Expenditure	4.9	8.3	5.1	9.7	-
Precision Equipment	Depreciation & Amortization	4.2	8.7	4.2	9.5	-
	R&D Expenditure	12.0	25.7	13.6	25.4	-
	Capital Expenditure Depreciation & Amortization R&D Expenditure	21.0	34.4	9.8	16.1	-
Imaging		7.2	16.3	10.0	20.7	-
		14.1	29.0	16.8	28.4	-
	Capital Expenditure	0.5	1.5	0.7	1.3	
Instruments	Depreciation & Amortization	0.8	1.6	0.8	1.7	
	R&D Expenditure	2.6	5.5	2.6	5.2	-
	Capital Expenditure	5.5	10.7	5.7	11.3	-
Other	Depreciation & Amortization	2.9	6.4	3.0	5.7	-
	R&D Expenditure	7.7	16.1	7.6	15.3	-
Corporate	Capital Expenditure	2.8	5.2	4.3	6.9	•
Assets	Depreciation & Amortization	1.7	3.2	1.7	4.6	-

 $[\]ensuremath{^*}$ Including intangible fixed assets except long-term prepaid expenses.

2011/3

8.Cash Dividends (yen: interim / year-end)

2011/3	2012/3	2013/3	2014/3	2015/3 (est.)
5.0 14.0	17.0 21.0	19.0 12.0	10.0 22.0	10.0 22.0

2013/3

9. Number of Employees *The figure does not include personnel dispatched to subsidiaries and associated companies

Consolidated	24,409	24,348	24,047	23,859
Non-Consolidated*	5,306	5,397	5,583	5,684
Outside Japan	14,998	14,429	13,985	13,691
Japan	9,411	9,919	10,062	10,168

2012/3

^{*} Starting the year ending March 2015, the depreciation method of the Nikon Group is standardized to the straight line method.